	Application No.	Applicant(s)
Notice of Allowability	10/789,261	BAUKUS ET AL.
	Examiner	Art Unit
	Joseph Nguyen	2815
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to the application filed on 2/26/2004.		
2. The allowed claim(s) is/are 12-17.		
3. The drawings filed on 26 February 2004 are accepted by the Examiner.		
4.		
 Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date 9/2/04,7/28/04, 2/26/04. 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material 	6. ☐ Interview Summary Paper No./Mail Da 98), 7. ☐ Examiner's Amend	te

DETAILED ACTION

Allowable Subject Matter

Claims 12-17 are allowed.

The following is an examiner's statement of reasons for allowance:

The reference (s) of record do not teach or suggest, either singularly or in combination at least the limitation of "removing a portion of said deposited first insulating layer; forming a buried silicon region of a second conductivity type within the silicon well region of the first conductivity type, under the removed portion of said deposited first insulating layer; depositing a second insulating layer over the first insulating layer and over the buried silicon region of the second conductivity type; forming a polysilicon gate region over the second insulating layer; and forming a source region of the second conductivity type and a drain region of the second conductivity type within the buried silicon well region, said source region and drain region contacting said buried silicon region of the second conductivity type" for claim 12.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Joseph Nguyen whose telephone number is (571) 272-1734. The examiner can normally be reached on Monday-Friday, 7:30 am- 4:30 pm. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas can be reached on (571) 272-1664. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306 for regular communications.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

JN February 25, 2005 ALLAN R. WILSON PRIMARY EXAMINER